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PATENT \$

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicants: Kim et al.  
Serial No.: 10/032,687  
Filed: December 28, 2001  
For: METHOD OF FORMING  
WIRING IN  
SEMICONDUCTOR DEVICES  
Group Art Unit: 2822  
Examiner: Maria F. Guerrero

I hereby certify that this paper is being  
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January 30, 2004

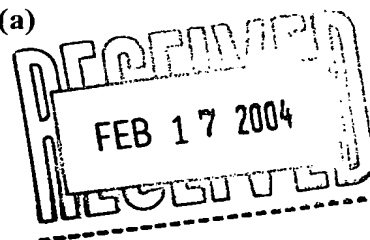
  
James P. Zeller  
Reg. No. 28,491

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PETITION UNDER 37 C.F.R. §1.136(a)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:



Applicants, by their attorneys, petition for a one-month extension of time to file a  
response to the official action of October 3, 2003.

Submitted herewith is the one-month extension fee of \$110.00.

Any additional required fee may be charged or any overpayment credited, to our

Deposit Account No. 13-2855.

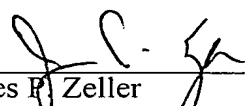
02/06/2004 MBIZUNES 00000015 10032687

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Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

January 30, 2004

By:   
James P. Zeller  
Reg. No. 28,491  
Attorneys for Applicants

6300 Sears Tower  
233 South Wacker Drive  
Chicago, Illinois 60606-6357  
(312) 474-6300